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INFORMATION DISCLOSURE STATEMENT BY APPLICANT

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Complete if Known

Application Number	10/038,585
Confirmation Number	1441
Filing Date	January 08, 2002
First Named Inventor	Olfa CHETAY
Art Unit	2857
Examiner Name	Unknown
Attorney Docket Number	Q67992

Sheet 1 of 1

U.S. PATENT DOCUMENTS

Examiner Initials*	Cite No. ¹	Document Number		Publication Date MM-DD-YYYY	Name of Patentee or Applicant of Cited Document
		Number	Kind Code ² (if known)		
TL		US 4,881,412	A	11-21-1989	NORTHEGE
TL		US 6,079,217	A	06-27-2000	JUDGE
		US			
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FOREIGN PATENT DOCUMENTS

Examiner Initials*	Cite No. ¹	Foreign Patent Document			Publication Date MM-DD-YYYY	Name of Patentee or Applicant of Cited Document	Translation ⁶
		Country Code ³	Number ⁴	Kind Code ⁵ (if known)			
TL		FR	2 734 362	A	11-22-1996	GEC ALSTHOM T & D SA	
TL		DE	42 06 845	A	09-09-1993	RATIONAL GMBH	
TL		EP	0 044 056	A	01-20-1982	AKAD GORNICZO HUTNICZA	

OTHER PRIOR ART - NON PATENT LITERATURE DOCUMENTS

Examiner Initials*	Cite No. ¹	Include name of the author (in CAPITAL LETTERS), title of the article (when appropriate), title of the item (book, magazine, journal, serial, symposium, catalog, etc.), date, page(s), volume-issue number(s), publisher, city, and/or country where published.	Translation ⁶
TL		PATENT ABSTRACTS OF JAPAN, vol. 1998, no. 8, 30 June 1998, & JP 10 068555 A (MITSUBISHI HEAVY IND LTD), 10 March 1998, *abstract	
TL		GUEHRIA, F.M. et al., "Compositional Reservoir Simulation: A New, Efficient, Fully Integrated Solution Technique For The Flow/Thermodynamic Equilibrium Equations", SPE PROCEEDINGS, XX, XX, 20 March 1991, pages 55-68, XP002035429	
TL		ZEISEL, D. et al., "A precise and robust quartz sensor based on tuning fork technology for (SF ₆)-gas density control", SENSORS AND ACTUATORS A, ELSEVIER SEQUOIA S.A., LAUSANNE, CH, vol. 80, no. 3, March 2000, pages 233-236, XP004192111, ISSN: 0924-4247	

Examiner Signature

TL

Date Considered

4-30-03

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